

10/579777

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## APPLICATION DATA SHEET

### APPLICATION INFORMATION

Application Number::	
Filing Date::	May 18, 2006
Application type::	Regular
Subject Matter::	Utility
Title::	Plasma Film-Forming Apparatus and Plasma Film-Forming Method
Attorney Docket No.::	101994.57726US
Request for Early Publication?::	No
Request for Non-Publication?::	No
Suggested Drawing Figure::	1
Total Drawing Sheets::	10
Small Entity?::	No
Petition included?::	No



## APPLICANT INFORMATION

Applicant one Authority Type::	Inventor
Primary Citizenship Country::	JAPAN
Status::	Full Capacity
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State or Province of mailing address::	Tokyo
Country of mailing address::	Japan
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### CORRESPONDENCE INFORMATION

Correspondence customer number:: 23911

### REPRESENTATIVE INFORMATION

Representative customer number:: 23911

### DOMESTIC PRIORITY INFORMATION

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
<b>This application is a</b>	<b>National Stage of</b>	<b>PCT/JP2004/017162</b>	<b>11/18/2004</b>

### FOREIGN PRIORITY INFORMATION

Country::	Application Number::	Filing Date::	Priority Claimed::
<b>JAPAN</b>	<b>2003-389469</b>	<b>11/19/2003</b>	<b>Yes</b>

### ASSIGNEE INFORMATION

Assignee Name:: TOKYO ELECTRON LIMITED  
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